EERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)				Docket No.		
Applicant(s): Martin E. Kordesch, Howard D. Bartlow, Richard L. Woodin				90065.001020/8011.00		
Serial No.	Filing Date	Examiner		Group Art Unit		
09/682,151	27 July 2001	Chris C. Chu		2815		
Invention: CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR						
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	is <u>Response to</u> th the United States Postal Serv ner for Patents, Washington, D.C.	. 20231 on Octobe		DENED TO THE ADDRESS OF THE STATE OF THE STA		
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(Typed or Printed Name of Person Mailing Correspondence)						
Kathlen G. Manual						
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Thereby certify that this	Power of Atte	orney (Identify type of correspondence	o)			
is being deposited with	n the United States Postal Serv					
			an envelope addressed to. The			
Assistant Commissioner for Patents, Washington, D.C. 20231 on October 1, 2002						
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		(Signature of Person Mo	niling Correspondence)			
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